

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination 10/709,563 GIBBS ET AL.	
		Examiner Roberts Culbert	Art Unit 1763	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-3,719,536	03-1973	Rheingold et al.	216/53
*	B	US-4,020,762	05-1977	Peterson, John O. H.	430/302
*	C	US-5,596,912	01-1997	Laurence et al.	76/107.1
*	D	US-4,944,986	07-1990	Zuel, David C.	428/156
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kohler, Michael "Etching in Microsystem Technology" pp.13-17 and 116-117. Wiley-VCH, 1999.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.